

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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## Title of Invention

PT COATING INITIATED BY INDIRECT ELECTRON BEAM  
FOR RESIST CONTACT HOLE METROLOGY

Application Number :

Confirmation Number:

First Named Applicant: Wei Lu

Attorney Docket Number: FIS920030308

Art Unit:

Examiner:

Search string: ( 5188705 ).pn

## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5188705	1993-02-23	Swanson et al.			

## Signature

Examiner Name	Date